

Course Schedule, group M17-207**MONDAY**

08:30 — 10:05	■	LEC	Opt	Military Training (2018-02-05 — 2018-05-14) ♣ dep.20
10:15 — 16:05	■	SEM	Opt	Military Training (2018-02-05 — 2018-05-14) ♣ dep.20

TUESDAY

10:15 — 13:30	■	PR	Elect	Industry Workshop (Scientific Research Work): Mathematical Modeling in Optics ♣ Chirikov S.N., Gonchukov S.A. ♣ dep.37
14:30 — 17:50	■	PR	Elect	Industry Workshop (Scientific Research Work): Photonics and Optoinformatics ♣ Gonchukov S.A., Protasov E.A. ♣ dep.37

WEDNESDAY

12:45 — 14:20	■	LEC		Optoelectronics (2018-02-07 — 2018-02-14) ♣ Krasnov V.V., Cheryomhin P.A. ♣ B-216
	■	SEM		Optoelectronics (2018-02-21 — 2018-05-16) ♣ Krasnov V.V., Cheryomhin P.A. ♣ B-216

THURSDAY

08:30 — 10:05	■	LEC		Integrated and Fiber Optics (2018-02-08 — 2018-02-22) ♣ Bufetov I.A. ♣ K-1102
	■	SEM		Integrated and Fiber Optics (2018-03-01 — 2018-05-17) ♣ Bufetov I.A. ♣ K-1102
10:15 — 11:50	■	LAB	Elect	Workshop: Computer Modeling In Optics ♣ Krasnov V.V. ♣ dep.37
12:45 — 14:20	■	LEC		Digital Methods In Optics And Photonics (2018-02-08 — 2018-02-22) ♣ Zlokazov E.Y. ♣ B-212
	■	SEM		Digital Methods In Optics And Photonics (2018-03-08 — 2018-05-17) ♣ Zlokazov E.Y. ♣ B-212
	■	SEM		Digital Methods In Optics And Photonics ♣ Zlokazov E.Y. ♣ dep.37
14:30 — 16:05	■	LEC		Physical Optics (2018-02-08 — 2018-03-22) ♣ Starikov R.S. ♣ K-210
	■	SEM		Physical Optics (2018-04-05 — 2018-05-17) ♣ Starikov R.S. ♣ K-210
	■	SEM		Physical Optics ♣ Starikov R.S. ♣ K-307

FRIDAY

10:15 — 11:50	■	LAB	Elect	Automated Measurement and Control Systems ♣ Naumov P.Y., Loginov V.A. ♣ E-311
	■	LAB	Elect	Workshop: Optic Systems Computer Modeling ♣ Cheryomhin P.A. ♣ V-109
12:45 — 14:20	■	SEM	Elect	English Language ♣ Andrianova S.V. ♣ B-303
	■	SEM	Elect	German Language ♣ Ruzhitskaya E.A. ♣ T-108
14:30 — 17:50	■	LAB	Elect	Latex Basics (2018-02-09 — 2018-03-30) ♣ Kuznetsov A.V. ♣ K-1102